



Docket No.: 4733 USA/W-C/W-C/JB1

## Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

For: ASSISTED RINSING IN A SINGLE)  
WAFER CLEANING PROCESS )

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. § 1.312  
(Amendment After Allowance)**

Sir:

In Response to the Notice of Allowance mailed on December 3, 2004, the Applicant respectfully requests the Examiner to enter the following amendment.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP \_\_\_\_\_  
COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450  
U.S. Patent and Trademark Office, Washington, D.C. 20231 on January 20, 2005.

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**Date of Deposit**

Teresa Mattox

**Name of Person Mailing Correspondence**

~~verso matto~~

**Signature**

January 28, 2005  
Date